



CS-97-110/112

GAU 2814

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August 28, 2000

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TECHNOLOGY CENTER 2800

To: Commissioner of Patents and Trademarks
Washington, D.C. 20231

Fr: George O. Saile, Reg. No. 19,572
20 McIntosh Drive
Poughkeepsie, NY 12603

Subject: Serial No. 09/186,388 11/05/98

B. LEE et al.

"N TYPE IMPURITY DOPING USING IMPLANTATION
OF P₂⁺ IONS OR As₂⁺ IONS"

Grp. Art Unit: 2814

G. PERALTA

RESPONSE PATENT OFFICE ACTION

Dear Sir:

In response to the Office Action dated
May 30, 2000 please consider the following arguments:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first
class mail in an envelope addressed to: Commissioner of
Patents and Trademarks, Washington, D.C. 20231 on
August 29, 2000.

Name Peggy Parisi

Signature Peggy Parisi

Date Aug. 29, 2000